

<p>FORM 1449 (Based on Form PTO-1449)</p> <p>PATENT AND TRADEMARK OFFICE</p> <p>INFORMATION DISCLOSURE CITATION</p> <p>(Use several sheets if necessary)</p> <p>Sheet 1 of 1</p>	ATTORNEY DOCKET NO.	SERIAL NO.
	NGC-00063(48-0059)	10/606,447
	APPLICANT	
	Jeffrey S. Hartlove et al.	
	FILING DATE	GROUP

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.	PG	6,002,744	12-14-1999	Hertz et al.		
2.	PG	5,577,092	11-19-1996	Kublak et al.		

FOREIGN PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes No
1.	PG	WO 02/32197 A1 (PCT/SE01/02217)	4-18-2002	Sweden		

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.	PG	Hansson, Bjorn A.M.; Rymell, Lars; Berglund, Magnus; Hemberg, Oscar; Janin, Emmanuelle; Mosesson, Sofia and Thoresen, Jalmar; "A Liquid-Xenon-Jet Laser-Plasma Source for EUV Lithography", 3rd International Workshop on EUV Lithography, 2001, 5 pps.
2.	PG	Wieland, M.; Wilhein, T.; Faubel, M.; Ellert, Ch.; Schmidt, M.; and Sublemontier, O.; "EUV and Fast Ion Emission from Cryogenic Liquid Jet Target Laser-Generated Plasma" Appl. Phys. B 72, 591-597 (2001)/Digital Object Identifier (DOI) 10.1007/s003400100542.
3.	PG	Rymell, L.; Berglund, M; Hansson, B.A.M.; and Hertz, H.M.; "X-Ray and EUV Laser-Plasma Sources Based on Cryogenic Liquid-Jet Target"; Biomedical and X-Ray Physics, Royal Institute of Technology, SE-10044 Stockholm, Sweden; Part of the SPIE Conference on Emerging Lithograph Technologies III, Santa Clara, California, March 1999; pps. 421-423.
4.	PG	Gouge, Michael J. and Fisher, Paul W.; "A Cryogenic Xenon Droplet Generator for Use in a Compact Laser Plasma X-Ray Source"; Feb. 11, 1997; pps. 2158-2162.
5.	PG	Klebniczki, J; Hebling, J.; Hopp, B.; Hajos, G. and Bor, Z.; "Fluid Jet with Variable Thickness in the range 5-20 mu m"; Meas. Sci. Technol. 5 (May 1994) 601-603.

Examiner: Paul Junzo	Date Considered: 11/28/04 11/28/04
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